Search Notes

_	
1100001100	
11000011100	

Application/Control No.	Applicant(s)/Patent Under Reexamination
	посманниции

10598997 NAKAMURA ET AL.

Examiner Art Unit

Mark L Shevin 1793

SEARCHED

Class	Subclass	Date	Examiner
148	408, 425, 674	11/03/2008 and 11/08/2008	MLS
204	298.12, 298.13	11/03/2008	MLS
420	435, 436	11/03/2008	MLS

SEARCH NOTES

Search Notes	Date	Examiner
Inventor name search (EAST, eDan, and Google Scholar)	11/03/2008	MLS
Assignee name search (Nippon Mining)	11/03/2008	MLS
IPC: C22C 19/07, C23C 14/34,35, H01F 41/18, H01L 21/285, C22F 1/10	11/03/2008 and	MLS
	11/08/2008	
Derwent: M13-G02A , M26-B08	11/03/2008	MLS
Search reports and written opinions for instant application and co-pending 10-598,502	11/03/2008	MLS
NPL search for Co-Cr-Pt-B sputterring target, lathe machining of targets, and surface roughness / polishing of targets	11/03/2008	MLS
Discussion with Jessee Roe about claims	11/03/2008	MLS
Updated search (US classes, IPC, Derwent, Inventor and Assignee name search)	05/07/2009	MLS
Updated search (US classes, IPC, Derwent, Inventor and Assignee name search)	12/08/2009	MLS
Updated search (US classes, IPC, Inventor and Assignee name search)	06/08/2010	MLS

INTERFERENCE SEARCH

Class	Subclass	Date	Examiner

/Mark L. Shevin/	

U.S. Patent and Trademark Office Part of Paper No.: 20100609